

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

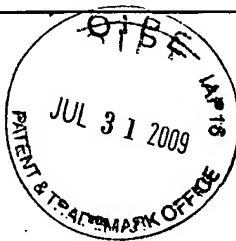
In re Application of

Dominik EISERT et al.

Serial No.: 10/523,551

Filed: October 18, 2005

For: GaN-Based Radiation-Emitting Thin-Layered  
Semiconductor Component



Examiner: Nguyen, Joseph H.  
Group Art: 2815

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 27, 2009

(Date of Deposit)

Lance J. Lieberman

Name of applicant, assignee or Registered Representative

Signature

July 27, 2009

Date of Signature

Mail Stop **Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

SIR:

In response to the Office Action dated April 27, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.